

Wide Range Gas Monitor

RADIATION MONITORING SYSTEMS FOR A LIFETIME OF SERVICE

Since 1965, General Atomics has been a recognized world leader in the design, manufacture, and support of high quality, extremely reliable radiation monitoring systems for the nuclear industry. Our unmatched technical expertise, support services, and extensive manufacturing and testing capabilities keep systems operating efficiently and safely for a lifetime of service.

Sample Conditioning Skid

Sample Detection Skid

RM-2000 Digital Radiation Processor

RM-2300 Control Room Display Assembly



Sample Conditioning Skid



Sample Detection Skid

Wide Range Gas Monitor System Assemblies

SAMPLE CONDITIONING SKID

- Separate particulate and iodine filter sets for each flow path
- Two prefilters and one sample filter in each set
- 4π lead shielding enclosures for the high concentration filters
- · Manual filter selection controls located inside enclosure
- Filter selections can be made locally or remotely
- Remote control grab sample assembly

The **Sample Conditioning Skid** is located down-stream from the Isokinetic Sample Probe Assembly. Each of the two sample flow paths is provided with two prefilters and one sample filter. The selectable prefilters prevent contamination of the detectors on the Sample Detection Skid by filtering particulates and iodine. The sample filter provides particulates and iodine samples for laboratory analysis.

SAMPLE DETECTION SKID

- RD-52 Gas Detector for low concentrations
- RD-72 Dual-Range Gas Detector for mid and high range concentrations
- 12-decade range
- 4π lead shielding for detectors and electronics
- · Long half-life integral checksources for each detector
- Automatic purge and isolation of RD-52 Gas Detector or RD-72
- Dual-Range Gas Detector when concentration is out of range
- Separate flow sensors, flow control valves, and pumps for each sample path

The Sample Detection Skid is located down-stream from the Sample Conditioning Skid. It monitors radioactive gas concentrations over a 12-decade range using three radiation detectors. Each of the two flow paths have separate pumps, valves flowmeters, relays, and control switches. The flow through the monitor is automatically controlled by the RM-2000 Digital Radiation Processor to maintain isokinetic sample flow rates from the Isokinetic Sample Probe Assembly.

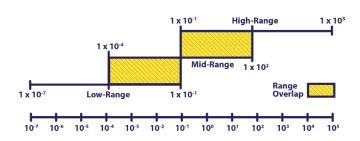
RM-2000 DIGITAL RADIATION PROCESSOR

- · 8-channel capability
- Data acquisition and control
 - » Multiple history files
- Menu-driven operator interface
- · Application-specific database
- · Local status indication
- Digital signal processing of analog signals
- · External digital communications
- · Automatic diagnostics/continuous self-test
- Electronic calibration
- Multi-channel analyzer
- Internal 120 Vac power filter
- Outlet for test instruments

The **RM-2000** performs data acquisition, analysis and display, as well as monitor control functions, alarm relays, analog outputs, and digital communications. The RM-2000 database, which can be programmed for specific applications by the user, contains the calibration constants for the RD-52 Gas Detector and RD-72 Dual- Range Gas Detector, alarm set-points, and history files. The RM-2000 is easy to maintain, providing electronically adjustable high voltage power supplies, location independent circuit cards, and a swing out card cage for improved accessibility. The RM-2000/CIJB can be located up to 500 ft. from the Sample Detection Skid.



RM-2000 Digital Radiation Processor

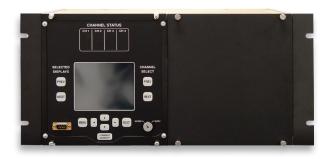


Concentration of Xe133 (µCi/cm3)

RM-2300 CONTROL ROOM DISPLAY ASSEMBLY

- Remote control of RM-2000 Radiation Processor
- · Easy menu-driven access to database items
- · Multi-channel, simultaneous display
- · Numerical and graphical display of radiation monitoring data
- · Provides alarm relay outputs

The **RM-2300** Control Room Display Assembly provides remote control and display for the Wide Range Gas Monitor system. The RM-2300 continuously polls the RM-2000 for the radiation level and operation status. It provides data collection and display, and alarm annunciation for the RM-2000.



RM-2300 Control Room Display Assemb;y

Power/Voltage 120 VAC, 50 to 60 Hz, 15 A nominal at the main power disconnect switch on the Sample Detection Skid which provides power to the Sample Detection and Sample Conditioning Skids PRM-2000 Microprocessor/CIJB	WIDE RANGE GAS MONITOR SYSTEM SPECIFICATIONS	
Coperational Range • Pressure Atmospheric • Temperature 39°F to 122°F (4°C to 50°C) • Humidity 120°F (49°C) maximum at 90% RH Sample Temperature 120°F (49°C) maximum at 70% RH Environmental Temperature 99°F to 122°F (4°C to 50°C) • RD-52 80°F to 122°F (4°C to 50°C) • Ranges Ranges and MDCs dependent on cosmic background and local fission product background 10° to 10°µCi/cm³ (Xe¹³³) with 1 mR/hr background Sensitivity RD-52 Kr ⁶⁵ 7.19E7 cpm/µCi/ml, Xe¹³³ (2.94E7 cpm/µCi/ml RD-72 Mid-Range Kr ⁶⁵ 1.51E4 cpm/µCi/ml, Xe¹³³ (1.42E4 cpm/µCi/ml RD-72 High-Range 15psig (0.10 MPa) maximum Sample Pressure 15psig (0.10 MPa) maximum Sample Flow Rate 1.0° ft.³/min (802 cm³/sec) nominal • Mid/High Range 0.06 ft.³/min (28 cm³/sec) nominal • Low Range 0.5 in. (1.3 cm) tube fitting • Low Range 0.5 in. (1.3 cm) tube fitting • Common Return Line 0.5 in. (1.3 cm) tube fitting • Common Return Line 0.6 in. (1.3 cm) tube fitting • Common Return Line 0.5 in. (1.3 cm) tube fitting • Common Return Line 0.5 in. (1.5 cm) tube fitting <td< td=""><td>Power/Voltage</td><td></td></td<>	Power/Voltage	
Operational Range Pressure Temperature To 59% (non-condensing) Sample Temperature 120°F (49°C) maximum at 90% RH 130°F (54°C) maximum at 70% RH Environmental Temperature PD-52 Sp°F to 122°F (4°C to 50°C) 39°F to 122°F (4°C to 50°C) 39°F to 122°F (4°C to 50°C) 39°F to 122°F (4°C to 50°C) Range' Ranges and MDCs dependent on cosmic background and local fission product background and local fission product background and local fission product background Kré* 1.51E4 cpm/µCi/rml, Xe ¹³⁰ 2.94E7 cpm/µCi/rml RD-72 Mid-Range RD-72 Mid-Range RD-72 High-Range RD-72 High-Range RD-72 High-Range RD-72 High-Range RD-72 High-Range RD-72 High-Range RD-72 Mid-Range DD-72 Mid-Range RD-72 Mid-Range DD-72 Mid-Range RD-72 Mid-Range DD-72 Mid-R	RM-2000 Microprocessor/CIJB	4.0 A nominal
* Pressure * Temperature * Tem	RM-2300 Control Room Display	2.5 A nominal
In 130°F (54°C) maximum at 70% RH Environmental Temperature • RD-52 • RD-52 • RD-72 39°F to 122°F (4°C to 50°C) 39°F to 122°F (4°C to 50°C) Range* Ranges and MDCs dependent on cosmic background and local fission product background Sensitivity RD-52 RD-72 Mid-Range RD-72 Mid-Range RD-72 High-Range RD-72 High-Range RD-72 High-Range 15psig (0.10 MPa) maximum Sample Flow Rate • Low Range • Mid/High Range • Oommon Return Line • Connecting Lines Overall System Accuracy Meets or exceeds U.S. Regulatory Guide 1.97 (Rev.3)	Pressure Temperature	39°F to 122°F (4°C to 50°C)
 RD-52 RD-72 39°F to 122°F (4°C to 50°C) 39°F to 122°F (4°C to 50°C) Range* Ranges and MDCs dependent on cosmic background and local fission product background Sensitivity RD-52	Sample Temperature	
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RD-52 Kr ⁸⁵ 7.19E7 cpm/μCi/ml, Xe ¹³³ 2.94E7 cpm/μCi/ml Kr ⁸⁵ 1.51E4 cpm/μCi/ml, Xe ¹³³ 1.42E4 cpm/μCi/ml Kr ⁸⁵ 1.51E4 cpm/μCi/ml, Xe ¹³³ 4.94 cpm/μCi/ml Sample Pressure 15psig (0.10 MPa) maximum Sample Flow Rate Low Range Mid/High Range 1.7 ft.³/min (802 cm³/sec) nominal 0.06 ft.³/min (28 cm³/sec) nominal 0.06 ft.³/min (28 cm³/sec) nominal 0.05 in. (1.3 cm) tube fitting 0.25 in. (0.64 cm) tube fitting 0.5 in. (1.3 cm) tube fitting 0.5 in. (Ranges and MDCs dependent on cosmic	10 ⁻⁷ to 10 ⁵ μCi/cm ³ (Xe ¹³³) with 1 mR/hr background
Sample Flow Rate • Low Range • Mid/High Range Sample Connections • Low Range • Mid/High Range • Mid/High Range • Mid/High Range • Mid/High Range • Common Return Line • Connecting Lines Overall System Accuracy 1.7 ft.³/min (802 cm³/sec) nominal 0.06 ft.³/min (28 cm³/sec) nominal 0.5 in. (1.3 cm) tube fitting 0.25 in. (0.64 cm) tube fitting 0.5 in. (1.3 cm)	RD-52 RD-72 Mid-Range	Kr ⁸⁵ 1.51E4 cpm/μCi/ml, Xe ¹³³ 1.42E4 cpm/μCi/ml
 Low Range Mid/High Range Sample Connections Low Range Mid/High Range Mid/High Range Mid/High Range Mid/High Range Common Return Line Connecting Lines Overall System Accuracy I.7 ft.³/min (802 cm³/sec) nominal 0.06 ft.³/min (28 cm³/sec) nominal 0.5 in. (1.3 cm) tube fitting 0.5 in. (0.64 cm) tube fitting 0.5 in. (1.3 cm) tube fitting Between Isokinetic Sample Probe Assembly manifold and Sample Conditioning Skid Meets or exceeds U.S. Regulatory Guide 1.97 (Rev.3) 	Sample Pressure	15psig (0.10 MPa) maximum
 Low Range Mid/High Range Common Return Line Connecting Lines Overall System Accuracy Los In. (1.3 cm) tube fitting 0.25 in. (0.64 cm) tube fitting 0.5 in. (1.3 cm) tube fitting Detween Isokinetic Sample Probe Assembly manifold and Sample Conditioning Skid per ANSI N13.1-1969 Meets or exceeds U.S. Regulatory Guide 1.97 (Rev.3) 	Low Range	
	Low RangeMid/High RangeCommon Return Line	0.25 in. (0.64 cm) tube fitting 0.5 in. (1.3 cm) tube fitting Between Isokinetic Sample Probe Assembly manifold and Sample Conditioning Skid
Quality Assurance Meets 10 CFR 50, Appendix B; ANSI N45.2	Overall System Accuracy	Meets or exceeds U.S. Regulatory Guide 1.97 (Rev.3)
	Quality Assurance	Meets 10 CFR 50, Appendix B; ANSI N45.2

*Custom options and Service Agreements are available

COMPLIANCE

- 10CFR50, Appendix B
- Reg.Guide 1.97
- NQA-1-2015
- ANSI N45.2, including applicable daughter standards
- Seismic IEEE 344
- Environmental IEEE 323
- SO 9001:2015, AS9100:2016 Certified
- ISO 14001:2015

